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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Gabric, *et al.*

Docket No.: 2006 VJ 33543 US

Serial No.: 10/586,788

Examiner: TBD

Filed: July 21, 2006

Art Unit: TBD

For: Plasma Excited Chemical Vapor Deposition Method, Silicon/Oxygen/Nitrogen-Containing-Material and Layered Assembly

Mail Stop: Amendment
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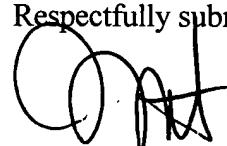
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The Applicants wish to bring to the attention of the Patent and Trademark Office the information noted on the enclosed form PTO/SB/08a that may be considered material to the examination of the above-identified application. Copies of the U.S. Patents cited are not being submitted. However, Applicants have included copies of the foreign patents.

No fee is due at this time, as this Information Disclosure Statement is being filed pursuant to 37 C.F.R. § 1.97(b)(3), before the mailing of a first Office Action on the merits.

Respectfully submitted,


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March 29, 2007

Date

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Certificate of Mailing via First Class Mail (37 C.F.R. § 1.8(a))

Date of Deposit: March 29, 2007

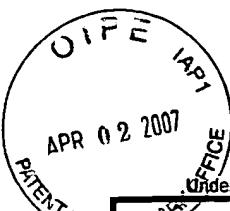
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Certificate of Mailing via First Class Mail (1 page)
Information Disclosure Statement (1 page)
Form PTO/SB/08a (1 page), citing fourteen (14) references
Copies of six (6) cited references
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Respectfully submitted,

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

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of

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Complete if Known

Application Number	10/586,788
Filing Date	July 21, 2006
First Named Inventor	Gabric, et al.
Art Unit	TBD
Examiner Name	TBD

Attorney Docket Number 2006 VJ 33543 US

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			
1	US-5,260,600		11-09-1993	Harada	
2	US-6,211,057 B1		04-03-2001	Lin, et al.	
3	US-2001/0019903 A1		09-06-2001	Shufflebotham, et al.	
4	US-6,445,072 B1		09-03-2002	Subramanian, et al.	
5	US-2003/0176055 A1		09-18-2003	Wu	
6	US-6,686,643 B2		02-03-2004	Schwarzl, et al.	
7	US-2004/0084749 A1		05-06-2004	Pamler, et al.	
8	US-7,033,926 B2		04-25-2006	Schindler, et al.	
US-					

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ - Number ⁴ - Kind Code ⁵ (if known)				
9	DE 41 18 165 A1		12-12-1991	Mitsubishi Electric Corp.		
10	JP 6216122		08-05-1994	Kawasaki Steel Co.		
11	DE 199 57 302 A1		05-31-2001	Infineon Technologies AG		
12	DE 101 09 778 A1		09-19-2002	Infineon Technologies AG		
13	DE 101 25 019 A1		12-05-2002	Infineon Technologies AG		
14	WO 03 019649 A2		03-06-2003	Infineon Technologies AG		

Examiner Signature	Date Considered
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹Applicant's unique citation designation number (optional). ²See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.

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